

Application Serial No.: 10/786,544
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ABSTRACT OF THE DISCLOSURE

A paste application apparatus including a Y-axis table, a Y-axis movement mechanism, a head mechanism main unit, and a syringe. The Y-axis movement table is configured to place a substrate thereon and to be capable of moving the substrate in a Y-axis direction. The Y-axis movement mechanism extends in the Y-axis direction. The head mechanism main unit extends in an X-axis direction and is moveable in the Y-axis direction by the Y-axis movement mechanism. The syringe is provided on the head mechanism main unit. The syringe is disposed above the substrate and is rendered movable in the X-axis direction. The application of paste contained in the syringe to a surface of the substrate is made by relative movement of the syringe and the substrate.